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PATENT
ATTORNEY DOCKET NO. 2253 P1 AKT (233001)
4/2/99

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : White et al.
Serial No.: 09/082,483
Filed : 5/20/98
Title : MODULAR SUBSTRATE PROCESSING SYSTEM

Art Unit: 2812
Examiner: Not Assigned

Assistant Commissioner for Patents
Washington, DC 20231

PRELIMINARY AMENDMENT

Prior to examination of application Serial No. 09/082,483, please amend it as follows:

IN THE CLAIMS:

1. (Amended) An apparatus for performing a process on a substrate, comprising:
a conveyor to support the substrate along a flow path;
a substrate transfer mechanism configured and arranged to remove the substrate
from and place another substrate on said conveyor; and
at least one processing island located adjacent to said flow path, [each] said
processing island having a valve for introduction and extraction of the substrate into and
out of an interior thereof.

3. (Amended) The apparatus of claim 1, wherein [each] said processing island includes a
load lock chamber and a processing chamber.

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01 FC:102
02 FC:103

156.00 OP
162.00 OP

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Date of Deposit March 24, 1999
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Rosa A. Caviedes

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